

**RESPONSE UNDER 37 C.F.R. § 1.116  
EXPEDITED PROCEDURE REQUESTED  
EXAMINING GROUP 1792**

**IN THE UNITED STATES PATENT AND TRADEMARK OFFICE**

|                      |  |                   |      |
|----------------------|--|-------------------|------|
| In re Application of | : Jin Zhao et al.  | Confirmation No.: | 4854 |
| Application Number   | : 10/623,757   |                   |      |
| Filed                | : July 21, 2003  |                   |      |
| Title                | : MAINTAINING A REACTOR CHAMBER OF A CHEMICAL<br>VAPOR DEPOSITION SYSTEM |                   |      |
| TC/Art Unit          | : 1792   |                   |      |
| Examiner:            | : Francis P. Smith   |                   |      |
|                      |  |                   |      |
| Docket No.           | : TI-35855 (0025.0220)   |                   |      |
| Customer No.         | : <b>23494</b>   |                   |      |

**MAIL STOP AF**  
Commissioner for Patents  
P.O. Box 1450  
Alexandria, VA 22313-1450

Sir:

**AMENDMENT AND RESPONSE TO OFFICE ACTION**

Responsive to the Final Office Action mailed June 12, 2008, and pursuant to 37 C.F.R. § 1.116, Applicants propose that this application be amended as follows:

**Amendments to the Claims** are reflected in the listing of claims in this paper.

**Remarks** follow the amendments section of this paper.